Monday Morning, October 21, 2019

Thin Films Division

Room A122-123 - Session TF+EM+MI+MN+OX+PS-MoM

Functional Thin Films: Ferroelectric, Multiferroics, and Magnetic Materials

Moderators: Christophe Vallee, LTM, Univ. Grenoble Alpes, CEA-LETI, France, Jessica Kachian, Intel Corporation

8:20am TF+EM+MI+MN+OX+PS-MoM1 A Room-Temperature Magnetoelectric Multiferroic made by Thin Film Alchemy, D.G. Schlom, Megan Holtz, Cornell University INVITED

Materials that couple strong ferroelectric and ferromagnetic order hold tremendous promise for next-generation memory devices. Meticulous engineering has produced novel ferroelectric and multiferroic materials, although known single-phase multiferroics remain limited by antiferromagnetic or weak ferromagnetic alignments, by a lack of coupling between the order parameters, or by having properties that emerge only well below room temperature. Here we construct single-phase multiferroic materials in which ferroelectricity and strong magnetic ordering are coupled near room temperature. Starting with hexagonal LuFeO3-a geometric ferroelectric with planar rumpling-we introduce individual monolayers of ferrimagnetic LuFe2O4 within the LuFeO3 matrix, that is, $(LuFeO_3)_m/(LuFe_2O_4)_1$ superlattices. The rumpling of the LuFeO₃ drives the ferrimagnetic LuFe₂O₄ into a ferroelectric state, reducing the LuFe₂O₄ spin frustration. This increases the magnetic transition temperature to 281K for m=9. Moreover, the ferroelectric order couples to the ferrimagnetism. enabling direct electric-field control of magnetism at 200 kelvin. Further, charged ferroelectric domain walls align at LuFe₂O₄ layers, resulting in charge transfer which increases the magnetic moment. We are currently pursuing higher temperature multiferroics by incorporating cubic spinels with high magnetic ordering temperatures, such as CoFe₂O₄, into the LuFeO₃ matrix. Our results demonstrate a design methodology for creating higher-temperature magnetoelectric multiferroics through epitaxial engineering.

9:00am TF+EM+MI+MN+OX+PS-MoM3 Magnetic Losses in FeGa/NiFe/Al₂O₃ Laminates for Strain-Mediated Multiferroic Micro-Antenna Applications, *Kevin Fitzell*, A. Acosta, C.R. Rementer, D.J. Schneider, Z. Yao, University of California, Los Angeles; C. Dong, Northeastern University; M.E. Jamer, D. Gopman, J. Borchers, B. Kirby, National Institute of Standards and Technology (NIST); N. Sun, Northeastern University; Y. Wang, G.P. Carman, J.P. Chang, University of California, Los Angeles

The ability to reduce the size of antennae would enable a revolution in wearable and implantable electronic devices. Multiferroic antennae, composed of individual ferromagnetic and piezoelectric phases, could reduce antenna size by up to five orders of magnitude through the efficient coupling of magnetization and electric polarization via strain. This strategy requires a material with strong magnetoelastic coupling and acceptable magnetic losses at high frequency.

Galfenol (Fe₈₄Ga₁₆ or FeGa) is a promising candidate material due to its large magnetostriction (200 $\mu\epsilon),$ large piezomagnetic coefficient (5 ppm/Oe), and high stiffness (60 GPa), but it is highly lossy in the GHz regime. On the other hand, Permalloy (Ni₈₁Fe₁₉ or NiFe) is a soft magnetic material that has very low loss in the GHz regime, with a ferromagnetic resonance (FMR) linewidth of 10 Oe, but almost no magnetostriction. In this work, nanoscale laminates containing alternating layers of FeGa and NiFe were fabricated via DC magnetron sputtering to combine the complementary properties of the two magnetic phases, resulting in a composite material with a small coercive field, narrow FMR linewidth, and high permeability (Rementer et al., 2017). Optical magnetostriction measurements confirmed that these laminates retain the large saturation magnetostriction of FeGa (200 µɛ) while enhancing the piezomagnetic coefficient (7 ppm/Oe), allowing for optimal piezomagnetic actuation at substantially reduced magnetic bias fields. Furthermore, multiferroic composites incorporating these magnetic laminates were studied via polarized neutron reflectometry, demonstrating uniform rotation of the individual layers' magnetization with an applied electric field across distances much larger than the exchange length of either material.

Due to the metallic nature of these FeGa/NiFe multilayer composites, however, resulting devices would be inefficient due to the generation of eddy currents at high frequency. To mitigate these losses, ultrathin layers of Al₂O₃ were incorporated into the multilayer materials to reduce the

conductivity and mitigate the generation of eddy currents. The effect of Al_2O_3 thickness, FeGa:NiFe volume ratio, and multilayer architecture on the soft magnetic properties was also studied, resulting in a 50% reduction in the FMR linewidth. Optimized magnetic laminates were shown to exhibit a small coercive field (<20 Oe), narrow ferromagnetic resonance linewidth (<50 Oe), and high relative permeability (>500) while maintaining excellent magnetoelastic coupling, showing great promise for the use of FeGa/NiFe/Al₂O₃ laminates in strain-mediated micro-scale communications systems.

9:20am TF+EM+MI+MN+OX+PS-MoM4 Multiferroic Gd-substituted HfO₂Thin Films, John Hayden, F. Scurti, J. Schwartz, J.-P. Maria, Pennsylvania State University

Modern ferroelectric technologies utilize perovskite structured materials, which have limited Si compatibility and modest bandgaps requiring thick films to reduce leakage current, hindering their implementation in realizable thin film devices. HfO₂ has been extensively researched as a gate dielectric thin film with excellent Si processing compatibility and has recently been found to exhibit ferroelectricity induced by a combination of impurity substitution, mechanical confinement by capping, intergranular surface area, and film thickness effects. This work investigates the microstructural characteristics, the ferroelectric response, and the potential for concomitant magnetic properties in sputtered Gd:HfO₂ thin films.

Gd-substituted HfO₂ thin films are a promising candidate as a multiferroic material, due to the presence of the magnetically active Gd^{3+} ion. Though substituting with Gd is known to induce ferroelectricity in HfO₂, the magnetic properties of Gd:HfO₂ have yet to be studied in depth. In this study, Gd:HfO₂ films are fabricated on TaN substrates by radio frequency sputtering of a composite Gd metal and HfO₂ oxide target in a mixed Ar and O₂ atmosphere. Grazing incidence x-ray diffraction is used to evaluate the suppression of the paraelectric monoclinic phase and stabilization of the ferroelectric orthorhombic phase. Electrical polarization measurements are used to study the room temperature spontaneous polarization in TaN/Gd:HfO₂/TaN metal-insulator-metal capacitors. Surface morphology of the films is characterized using atomic force microscopy, while magnetic properties are measured by variable temperature magnetometry. Initial magnetometry shows that Gd-substituted HfO₂ exhibits remnant magnetization at room temperature.

The scalability and simplicity of $Gd:HfO_2$, if it exhibits magnetoelectric coupling, make it an attractive model system for future developments in thin film multiferroics, having potential impacts for spintronics and other magnetoelectronic devices.

9:40am TF+EM+MI+MN+OX+PS-MoM5 Epitaxial Growth of Antiferromagnetic NiO Films by Off-axis Sputtering for Spintronic Devices, A. Churikova, G.S.D. Beach, Massachusetts Institute of Technology; Larry Scipioni, A. Shepard, J. Greer, T. Newhouse-Illige, PVD Products, Inc.

High-quality epitaxial growth of antiferromagnetic thin films is essential for future spintronic devices, as it allows small antiferromagnetic domain sizes and efficient electrical manipulation of domain walls via reading and writing currents. Antiferromagnetic materials are candidates for ultrafast operation due to THz antiferromagnetic spin dynamics, high packing densities due to the absence of stray magnetic fields, and stability due to insensitivity to external magnetic fields [1,2]. Meanwhile, the long spin diffusion lengths [3] and theoretically predicted superfluid transport of spin currents [4] in antiferromagnetic insulators are crucial for low-power device operation. The electrical control of magnetic spin textures has been thus far realized in epitaxially grown NiO on MgO substrates [5] and ferrimagnetic maghemite (y–Fe2O3) and magnetite (Fe3O4) thin films [6].

We report the preparation of antiferromagnetic NiO thin films with (111) orientation on *c*-plane sapphire (1000) substrates by off-axis RF magnetron sputtering from a NiO target. The off-axis angle was 45°, and the sputtering pressure was 5 mTorr. Samples were grown with thicknesses ranging from 5 - 50 nm, and with growth temperatures from room temperature to 600°C, to determine optimum conditions. Structural characterization by x-ray diffraction demonstrates a high degree of epitaxy across a range of deposition temperatures and thicknesses. The deposition temperature and thickness dependence of epitaxial quality is investigated, with a characterization of the strain state, mosaicity, and crystallographic relationship between substrate and film. Evidence for antiferromagnetic order forming domains in NiO is provided via magnetic characterization of high quality epitaxial antiferromagnetic films for practical spintronics devices.

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 J. Železný, P. Wadley, K. Olejník, A. Hoffmann, and H. Ohno, Nat. Phys. 14, 220 (2018)

[2] V. Baltz, A. Manchon, M. Tsoi, T. Moriyama, T. Ono, and Y. Tserkovnyak, Rev. Mod. Phys. 90, 015005 (2018).

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[5] T. Moriyama, K. Oda, T. Ono, Sci. Rep. 8, 14167 (2018).

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10:00am TF+EM+MI+MN+OX+PS-MoM6 Structural and Magnetic Properties of CoPd Alloys for Non-Volatile Memory Applications, S. Gupta, J.B. Abugri, B.D. Clark, University of Alabama; P. Komninou, Aristotle University of Thessaloniki; Sujan Budhathoki, A.J. Hauser, P.B. Visscher, University of Alabama

A study of perpendicular magnetic anisotropy (PMA) CoPd alloys is presented as a simple means of pinning MgO-based perpendicular magnetic tunnel junctions (pMTJs) for spin transfer torque magnetic tunnel junction (STT-MRAM) applications. A compositional study of the Co_xPd_{100-x} alloys at 50 nm thickness showed that the maximum coercivity and anisotropy was found for Co₂₅Pd₇₅. Perpendicular magnetic tunnel junction stacks were deposited using different compositions of CoPd. Current-inplane tunneling measurements indicated that the TMR values roughly correlated with the coercivity and anisotropy of the single layers. A thickness study indicated that the alloy was fully perpendicular for thicknesses as low as 20 nm. Various seed layers were employed to optimize the coercivity of the Co₂₅Pd₇₅ layer. Magnetometry, X-ray diffraction (XRD), scanning electron microscopy (SEM) and high resolution transmission electron microscopy studies were carried out to relate the magnetic and structural properties of these layers. These studies showed that the highest coercivity Co25Pd75 was achieved on a seed layer of Ta/Pd which helped to crystallize the CoPd layer in an fcc (111) orientation.

10:40am TF+EM+MI+MN+OX+PS-MoM8 Size Effects of the Electromechanical Response in Ferroic Thin Films: Phase Transitions to the Rescue, Nazanin Bassiri-Gharb, Georgia Institute of Technology INVITED

Silicon-integrated ferroelectric thin films have been leveraged over the last two decades for fabrication of high performance piezoelectric microelectromechanical systems (MEMS) devices. Ceramic Pb(Zr_xTi_{1-x})O₃(PZT) thin films have been often the material of choice, due to their large electromechanical response, especially at morphotropic phase boundary compositions (MPB at x ~0.52), where co-existence of multiple crystallographic distortions can enhance extrinsic electromechanical contributions. However, ferroelectric thin films suffer from extrinsic size effects that lead to deteriorated piezoelectric properties in thin and ultrathin films. Here we report on different strategies for processing of thin films with enhanced piezoelectric response with respect to traditionally processed PZT thin films.

Specifically, we will discuss preparation of superlattice-like polycrystalline PZT thin films through chemical solution depositions, polycrystalline relaxor-ferroelectric thin films (PMN-PT), and finally alternative non-ferroelectric compositions, where the electric field-induced phase transitions can result in substantial enhancement in thinner films, even where traditional

11:20am TF+EM+MI+MN+OX+PS-MoM10 Ferroelectrics Meet Ionics in the Land of van der Waals, S. Neumayer, Center for Nanophase Materials Sciences, Oak Ridge National Laboratory; J. Brehm, Vanderbilt University; M.A. McGuire, Oak Ridge National Laboratory; M.A. Susner, Air Force Research Laboratory; E. Eliseev, National Academy of Sciences of Ukraine; S. Jesse, S.V. Kalinin, Center for Nanophase Materials Sciences, Oak Ridge National Laboratory; A.N. Morozovska, National Academy of Sciences of Ukraine; S. Pantelides, Vanderbilt University; N. Balke, Petro Maksymovych, Center for Nanophase Materials Sciences, Oak Ridge National Laboratory

Van der Waals crystals of metal thiophosphates can be thought of as derivatives of transition metal dichalcogenides where 1/3 of metal atoms is replaced with diphosphorous, thereby stabilizing the remaining 2/3 of metal ions in low oxidation states.1 Consequently, thiophosphates enable ultrathin magnetic, ferroelectric and Mott insulating materials, in q2D

materials while also providing new opportunities for multifunctional interfaces.

Of particular interest is CuInP₂S₆, where ferroelectricity emerges out of ionically conducting state .2,3 In this work, we discuss unusual and perhaps anomalous properties observed in CuInP₂S₆ in both states.

CulnP₂S₆ exhibits giant negative electrostriction ($Q_{33} = -3.2 \text{ m}^4/\text{C}^2$), which leads to large piezoelectric coefficients despite small polarization values and increase of Tc with applied pressure. It's the only material other than polymer PVDF for which such behavior is experimentally confirmed. Density functional theory reveals that the reason for negative electrostriction is a slight movement of Cu ions into the van der Waals gap due to anharmonicity of the potential well.4 Moreover, under high compressive strain, Cu starts to form interlayer bonds with sulfur across the van der Waals gap, leading to an additional phase of high polarization. Consequently, the potential distribution exhibits 4 instead of the usual two minima - a quadruple well, that is precisely tunable by strain. In the paraelectric state above ~70°C, Cu ion mobility drastically increases. Intriguingly, Cu can be reversibly extracted out of the lattice without visible damage. Finally, the selenide sibling CuInP₂Se₆, exhibits a lower transition temperature and propensity toward antiferroelectric ordering under the effect of depolarizing fields. In this material, we have for the first time observed piezoelectric response confined to domain walls (opposite to ferroelectrics), fulfilling the long-standing predictions for polar antiferroelectric domain walls and providing a new model system for emergent properties of topological defects in ferroic order parameter fields.

Research sponsored by Division of Materials Science and Engineering, Basic Energy Sciences, US Department of Energy. Microscopy was conducted at the Center for Nanophase Materials Sciences, which is a DOE Office of Science User Facility.

1Susner et al, Adv. Mater. 29,1602852 (2018)

2Neumayer et al, Phys. Rev. Materials 3, 024401 (2019)

3Balke et al, ACS Appl. Mater. Interfaces 10, 27188 (2018)

⁴Brehm et al, in review

11:40am TF+EM+MI+MN+OX+PS-MoM11 Adsorption-controlled Epitaxial Growth of the Hyperferroelectric Candidate LiZnSb on GaSb (111), D. Du, P. Strohbeen, University of Wisconsin - Madison; H. Paik, Cornell University; C. Zhang, P. Voyles, Jason Kawasaki, University of Wisconsin - Madison A major challenge for ferroelectric devices is the depolarizing field, which competes with and often destroys long-range polar order in the limit of ultrathin films. Recent theoretical predictions suggest a new class of materials, termed hyperferroelectics [1], should be immune to the depolarizing field and enable ferroelectric devices down to the monolayer limit. Here we demonstrate the epitaxial growth of hexagonal LiZnSb, one of the hyperferroelectric candidate materials, on GaSb (111) substrates. Due to the high volatility of all three atomic species, we find that stoichiometric films can be grown in a thermodynamically adsorptioncontrolled window, using an excess zinc flux. Outstanding challenges remain in controlling the point defects of LiZnSb and in controlling polytypism. While the films primarily grow in a hexagonal "stuffed wurtzite" phase (space group P63mc), which is has the desired polar structure, there exists a competing cubic "stuffed zincblende" polymorph that is nonopolar (F-43m). We will discuss our strategy towards controlling defects and polytypism in LiZnSb, which is based in large part on the wurtzite - zincblende polytypism observed in InAs. We will also present preliminary electrical measurements on phase pure ferroelectric capacitor structures.

This work was supported by the Army Research office (W911NF-17-1-0254) and the National Science Foundation (DMR-1752797).

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